

O P R E  
JUN 09 2005

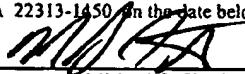
AF  
ZEW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Fernando Gonzalez et al.  
  
Serial No.: 10/081,915  
  
Filed: February 22, 2002  
  
For: METHOD FOR FORMING  
CONDUCTORS IN A  
SEMICONDUCTOR DEVICE

§ Group Art Unit: 2814  
§  
§ Examiner: Peralta, Ginette  
§  
§ Atty. Docket: MCRO:125--4/FLE  
94-0281.04  
§

Mail Stop Appeal Brief-Patents  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Appeal Brief-Patents, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
June 6, 2005 Date	Michael G. Fletcher 

**APPEAL BRIEF PURSUANT TO 37 C.F.R. §§ 41.31 AND 41.37**

This Appeal Brief is being filed in furtherance to the Notice of Appeal mailed on April 1, 2005, and received by the Patent Office on April 6, 2005.

1. **REAL PARTY IN INTEREST**

The real party in interest is Micron Technology, Inc., the Assignee of the above-referenced application by virtue of the Assignment recorded at reel 7889, frame 0678, and dated February 23, 1996.